

<b>Notice of References Cited</b>	Application/Control No. 10/626,391	Applicant(s)/Patent Under Reexamination POWELL ET AL.	
	Examiner Donald Heckenberg	Art Unit 1722	Page 1 of 1

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	C	US-5,501,784	03-1996	Lessmollmann et al.	205/67
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	M	US-			

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**NON-PATENT DOCUMENTS**

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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.